

Docket No.: 59516-052



IPU

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Zi-Kui LIU, et al.	:	Confirmation Number: 1022
Application No.: 10/784,899	:	Group Art Unit: 1775
Filed: February 24, 2004	:	Examiner: to be assigned
For: BORIDE THIN FILMS ON SILICON	:	

PRELIMINARY AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please amend the application as follows.

BEST AVAILABLE COPY